

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/025,851	BANG, JEONG IL	
Examiner	Art Unit	
Gabriel L. Chu	2114	

SEARCHED						
Class	Subclass	Date	Examiner			
714	34	6/3	M(
	38	6/2	1			
	48	6/2				
717	127	613	MC			

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Text Search	6/3	TC		
IN/cov	5/3/	71(
TEEE, ACM	5(31	2		